Docket No. 240883US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Maki HAMAGUCHI

SERIAL NO: NEW APPLICATION GAU:

FILED: HEREWITH EXAMINER:

FOR: COMPONENT OF GLASS-LIKE CARBON FOR CVD APPARATUS AND PROCESS FOR PRODUCTION

THEREOF

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Norman F. Oblon

Registration No. 24,618

C. Irvin McClelland Registration Number 21,124

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Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

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Tel. (703) 413-3000 Fax (703) 413-2220 (OSMMN 05/03)

LIST OF RELATED CASES

| | Serial or | Filing or | Inventor/ |
|---------------|---------------|------------|------------------|
| Docket Number | Patent Number | Issue Date | Applicant |
| 208931US0 | 09/863,383 | 05/24/01 | HAMAGUCHI, |
| | | | et al. |

DOCKET NO: 240883US0 Sheet <u>1</u> of <u>2</u>

IN RE APPLICATION OF: Maki HAMAGUCHI

SERIAL NO: New Application

FILED: Herewith

FOR: COMPONENT OF GLASS-LIKE CARBON FOR CVD APPARATUS AND PROCESS

FOR PRODUCTION THEREOF

STATEMENT OF RELEVANCY

Reference AJ (JP 2002-43397) on Form PTO- 1449:

This reference relates to a susceptor having an arithmetric average roughness of 1-10 micron stipulated by JIS 0601.

Reference AK (JP 2001-342068) on Form PTO- 1449:

This reference relates to a vitreous carbon material.

Reference AL (JP 2001-332504) on Form PTO-1449:

This reference relates to a CVD inner tube made of glass like carbon.

Reference AM (JP 11-189471) on Form PTO- 1449:

This reference relates to a roll made of vitrified carbon, its production, plasma generator, its chamber inner wall protecting member, protection of the chamber inner wall and plasma treatment.

Reference AN (JP 11-189470) on Form PTO- 1449:

This reference relates to a cylinder made of vitrified carbon, its production, plasma generator, its chamber inner wall protecting member, protection of the chamber inner wall and plasma treatment.

Reference AO (JP 10-209064) on Form PTO- 1449:

This reference relates to a wafer boat member for semiconductor heat treatment and wafer boat for semiconductor heat treatment.

Reference AP (JP 9-208316) on Form PTO- 1449:

This reference relates to a glassy carbon material and its production.

DOCKET NO: 240883US0 Sheet <u>2</u> of <u>2</u>

IN RE APPLICATION OF: Maki HAMAGUCHI

SERIAL NO: New Application

FILED: Herewith

FOR: COMPONENT OF GLASS-LIKE CARBON FOR CVD APPARATUS AND PROCESS

FOR PRODUCTION THEREOF

STATEMENT OF RELEVANCY

Reference AQ (JP 9-7954) on Form PTO- 1449:

This reference relates to a vitreous carbon nozzle for vapor growing apparatus.

Reference AR (JP 6-86662) on Form PTO- 1449:

This reference relates to a susceptor for CVD, the surface of which is coated with vitreous carbon.

Reference AS (JP 64-47019) on Form PTO- 1449:

This reference relates to a glassy carbon coated susceptor.

Reference AT (JP 7-53635) on Form PTO- 1449:

This reference relates to a glassy carbon susceptor and production thereof.

| Form PTO 1449 U.S. DEPARTMENT OF COMMERCE (Modified) PATENT AND TRADEMARK OFFICE | | ATTY DOCKET NO. | | SERIAL NO. | | | | | | |
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| | | APPLICANT | | | | | | | | |
| LIST OF REFERENCES CITED BY APPLICANT | | Maki HAMAGUCHI | | | | | | | | |
| | | FILING DATE | | GROUP | | | | | | |
| | | HEREWITH | | | | | | | | |
| | | | | U.S. PATENT DOCUMENTS | | | | | | |
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| | | | FO | REIGN PATENT DOCUMENTS | | | | | | |
| | | DOCUMENT NUMBER | DATE | COUNTRY | TRANSLATION YES | | LATION NO | | | |
| | AJ | 2002-43397 | 02/08/02 | Japan (with English Abstract) | | | × | | | |
| | AK | 2001-342068 | 12/11/01 | Japan (with English Abstract) | | | x | | | |
| | AL | 2001-332504 | 11/30/01 | Japan (with English Abstract and Corre U.S. Publication 2002/0017242A1) | | | x | | | |
| | AM | 11-189471 | 07/13/99 | Japan (with English Abstract) | | | × | | | |
| | AN | 11-189470 | 07/13/99 | Japan (with English Abstract) | | | × | | | |
| | AO | 10-209064 | 08/07/98 | Japan (with English Abstract) | | | × | | | |
| | AP | 9-208316 | 08/12/97 | Japan (with English Abstract) | | | × | | | |
| | AQ | 9-7954 | 01/10/97 | Japan (with English Abstract) | | | × | | | |
| | AR | 6-86662 | 11/02/94 | Japan (with English Abstract) | | | | × | | |
| | AS | 64-47019 | 02/21/89 | Japan (with English Abstract) | | | | × | | |
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| | | OTHER RE | FERENCES (| (Including Author, Title, Date, Pertinen | t Pages, e | tc.) | | | | |
| | US Patent Application Publication US 2002/0017242A1, published February 14, 2002, Application No. 09/863,383 filed AW May 24, 2001 | | | | | | | | | |
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| | AZ | | | Additional References sheet(s) attached | | | | | | |
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